

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Q1P R JC177  
MAILED 12/10/2001  
Re Application of

Ghad ALMOGY, et al.

Serial No.: 09/641,137

: Group Art Unit: 2877

Filed: August 16, 2000

: Examiner: H. Pham

For: VARIABLE ANGLE ILLUMINATION WAFER INSPECTION SYSTEM

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
Washington, DC 20231

Sir:

Noting the Office Action of September 17, 2001 wherein restriction has been required, Applicant(s) hereby elect, with traverse, Group I (claims 1-24), species b) (claims 8-11 and 19-22). Reconsideration and withdrawal of the restriction is requested in view of MPEP §803, which states that "if the search and examination of an entire application can be made without serious burden, the examiner must examine it on the merits, even though it includes claims to independent or distinct inventions." It is submitted that the pending claims of Group I are sufficiently related so as not to present serious burden on the Examiner's search and examination. Rejoinder is requested upon allowance of the generic claims.

Respectfully submitted,  
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